I hereby certify that this correspondence is being deposited with the United States Pelice de PCT/PTO 2 1 SEP 2000 as Express mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 21 2005

PATENT

September 21,005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Johnson et al.

Group Art Unit: N/A

Serial No.: N/A

Examiner: N/A

Filed: Herewith

Docket No.: 297/171 PCT/US

Confirmation No.: N/A

For: METHODS AND SYSTEMS FOR SINGLE OR MULTI-PERIOD EDGE DEFINITION

LITHOGRAPHY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

Early passage of the subject application to issue is earnestly solicited.

10/550040

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Although it is believed that no fee is due, the Commissioner is hereby authorized to charge any fees associated with the filing of this Information Disclosure Statement to Deposit Account No. <u>50-0426</u>.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.

Date: 9-21-65 By:

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Enclosures

Customer No: 25297

JC20 Rec'd PCT/PTO 21 SEP 2005

Sheet 1 of 2

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office List of Documents Cited by Applicant	Attorney Docket No. 297/171 PCT/US Serial No.		
	Applicant(s): Johnson et al.		
	Filing Date: Herewith	Group	

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing date if Appropriate
	1.	6,709,929	03/23/2004	Zhang et al.			
	2.	6,593,065	07/15/2003	Scherer			
	3.	6,214,246	04/10/2001	Craighead			
	4.	5,151,757	09/29/1992	Enoki et al.			
	5.	5,838,030	11/17/1998	Liu et al.			
	6.	6,242,293	06/05/2001	Danzilio			
	7.	6,008,509	12/28/1999	Inai et al.			
	8.	6,309,580	10/30/2001	Chou			
_	9.	6,566,704	05/20/2003	Choi et al.			
	10.	6,593,065	07/15/2003	Scherer			
	11.	6,755,984	06/29/2004	Lee et al.			

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		FC	DREIGN PATENT	DOCUMENTS)/55004 0	
Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known)	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	
	12.	JP 2004-034270	02/05/2004	II et al.		
	13.	JP 2003-073859	03/12/2003	Wada et al.		
	14.	JP 2003-045325	02/14/2003	Hatai et al.		
	15.	EP 1319948 A2	06/18/2003	Dong		
Examiner Initials	iner Cite Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc.					Т
	1	Include Author (in CAPITAL	OTHER DOCU			т
16	16. Commonly-assigned, co-pending U.S. Patent Application entitled, "Methods for Nanoscale Structures from Optical Lithography and Subsequent Lateral Growth," (Serial No. not yet assigned) (filed September 21, 2005).					
	17.	International Search Report and Written Opinion in PCT Application No. PCT/US04/08724 (November 19, 2004).				
	18. International Preliminary Report on Patentability in PCT Application No. PCT/US04/08724 (May 31, 2005).				on No.	
	19.	9. International Search Report in PCT Application No. PCT/US04/08725 (February 28, 2005)				

EXAMINER	DATE CONSIDERED	

^{*}Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.